

<div style="display: flex; justify-content: center; align-items: center;"> <div style="border: 1px solid black; border-radius: 50%; padding: 10px; text-align: center; margin-right: 10px;"> OIP E JC176 APR 23 2004 PATENT & TRADEMARK OFFICE </div> <div style="text-align: right; margin-right: 20px;">#0404</div> </div> <p>LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)</p>				ATTY. DOCKET NO.: 4717-5499		APPLICATION SERIAL NO.: 10/733,431		
				APPLICANT: Cecile BERNE et al.				
				FILING DATE: December 10, 2003		GROUP: 2812		
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
EP	AA	5,877,070	3/1999	Goesele et al.	438	458		
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FOREIGN PATENT DOCUMENTS								
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							YES	NO
EP	AG	FR 2767416 w/ English Abstract	2/1999	France	4,303,468		X	
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EP	AK	B. Aspar et al: XP001050558 "The Generic Nature Of The Smart-Cut Process For Thin Film Transfer", Journal Of Electronic Materials, Vol. 30, No. 7, 22 , pp. 834-840, (2001)						
EP	AL	B. Aspar et al: XP000884996, "Smart-Cut Technology: An Industrial Application Of Ion Implementation Induced Cavities", Materials Research Society Symposium Proceedings, Materials Research Society, Vol. 510, No. 13, pp 381-393 (19998)						
	AM							
EXAMINER					DATE CONSIDERED			
Evan Per+					4-28-05			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								